

Docket No. 214814US0  
IN RE APPLICATION OF: *Yasumichi MIYAKAWA*  
SERIAL NO: 09/975,262  
FILED: October 12, 2001  
FOR: METHOD FOR PRODUCING A SILICON NITRIDE FILTER



1731  
-Inc-12

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required  
 Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.  
 Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	13	MINUS	20	0	x \$18 =	\$0.00
INDEPENDENT	3	MINUS	3	0	x \$86 =	\$0.00
<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS				+ \$290 =	\$0.00	
TOTAL OF ABOVE CALCULATIONS					\$0.00	
<input type="checkbox"/> Reduction by 50% for filing by Small Entity					\$0.00	
<input type="checkbox"/> Recordation of Assignment				+ \$40 =	\$0.00	
					TOTAL	\$0.00

- A check in the amount of \$0.00 is attached.  
 Credit card payment form is attached to cover the fees in the amount of \$0.00  
 Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.  
 If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Norman F. Oblon

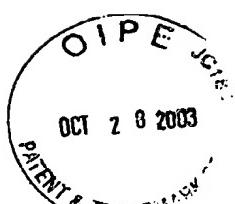
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Appln. No. 09/975,262  
Reply to the Office Action of July 29, 2003

214814US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Naomichi MIYAKAWA : GROUP ART UNIT: 1731

SERIAL NO.: 09/975,262 :

FILED: OCTOBER 12, 2001 : EXAMINER: FIORILLA, C.

FOR: METHOD FOR PRODUCING A  
SILICON NITRIDE FILTER

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Official Action of July 29, 2003, please amend the above-identified application as follows.

**Amendments to the specification** begin on page 2 of this paper.

**Amendments to the claims** begin on page 3 of this paper.

**Remarks/comments** begin on page 7 of this paper.